Hartmut Bracht

List of Publications by Year in descending order

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109321 123424 4,033 107 35 61 citations h-index g-index papers 107 107 107 1955 docs citations times ranked citing authors all docs

#	Article	IF	CITATIONS
1	Atomistic simulations on the relationship between solid-phase epitaxial recrystallization and self-diffusion in amorphous silicon. Journal of Applied Physics, 2022, 131, .	2.5	3
2	Retarded boron and phosphorus diffusion in silicon nanopillars due to stress induced vacancy injection. Journal of Applied Physics, 2022, 131, 075702.	2.5	1
3	Electrochemical Proton Intercalation in Vanadium Pentoxide Thin Films and its Electrochromic Behavior in the nearâ€IR Region. ChemistryOpen, 2021, 10, 340-346.	1.9	2
4	Impact of oxygen on gallium doped germanium. AIP Advances, 2021, 11, 065122.	1.3	3
5	Focused Ion Beam Sample Preparation for <i>In Situ</i> Thermal and Electrical Transmission Electron Microscopy. Microscopy and Microanalysis, 2021, 27, 828-834.	0.4	7
6	Comparison of Experimental STEM Conditions for Fluctuation Electron Microscopy. Microscopy and Microanalysis, 2020, 26, 1100-1109.	0.4	8
7	Diffusion of boron in germanium at 800–900 °C revisited. Journal of Applied Physics, 2020, 127, 025703.	2.5	3
8	Defect distribution in boron doped silicon nanostructures characterized by means of scanning spreading resistance microscopy. Journal of Applied Physics, 2020, 127, .	2.5	5
9	Fluctuation electron microscopy on silicon amorphized at varying self ion-implantation conditions. Journal of Applied Physics, 2019, 126, 095707.	2.5	5
10	Structural and Thermal Characterisation of Nanofilms by Time-Resolved X-ray Scattering. Nanomaterials, 2019, 9, 501.	4.1	3
11	Quantitative scanning spreading resistance microscopy on n-type dopant diffusion profiles in germanium and the origin of dopant deactivation. Journal of Applied Physics, 2019, 125, .	2.5	11
12	Self-Holding Optical Actuator Based on a Mixed Ionic–Electronic Conductor Material. ACS Photonics, 2019, 6, 1182-1190.	6.6	8
13	Analysis of medium-range order based on simulated segmented ring detector STEM-images: amorphous Si. Ultramicroscopy, 2019, 200, 169-179.	1.9	8
14	Self-diffusion in single crystalline silicon nanowires. Journal of Applied Physics, 2018, 123, 161515.	2.5	7
15	Self-Diffusion in Amorphous Silicon by Local Bond Rearrangements. Physical Review Letters, 2018, 120, 225902.	7.8	16
16	Towards fabrication of 3D isotopically modulated vertical silicon nanowires in selective areas by nanosphere lithography. Microelectronic Engineering, 2017, 179, 74-82.	2.4	32
17	Thermal transport across isotopic 28Si/mSi interfaces. Computational Materials Science, 2017, 139, 354-360.	3.0	1
18	Ion-Beam-Induced Atomic Mixing in Ge, Si, and SiGe, Studied by Means of Isotope Multilayer Structures. Materials, 2017, 10, 813.	2.9	7

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19	Ion-beam induced atomic mixing in isotopically controlled silicon multilayers. Journal of Applied Physics, 2016, 120, 185701.	2.5	6
20	Ultrafast study of phonon transport in isotopically controlled semiconductor nanostructures. Physica Status Solidi (A) Applications and Materials Science, 2016, 213, 541-548.	1.8	5
21	Molecular dynamics simulations of thermal transport in isotopically modulated semiconductor nanostructures. Physica Status Solidi (A) Applications and Materials Science, 2016, 213, 549-556.	1.8	10
22	Self-diffusion in crystalline silicon: A single diffusion activation enthalpy down to <mml:math xmlns:mml="http://www.w3.org/1998/Math/MathML"> <mml:mrow> <mml:mn>755</mml:mn> <mml:msup> <mml:width="0.16em"></mml:width="0.16em"> <mml:mo>\hat{a}^{\sim} </mml:mo> </mml:msup> <mml:mi mathvariant="normal"> C </mml:mi> </mml:mrow> </mml:math> . Physical Review B, 2016, 94, .	:mspace 3.2	41
23	Vacancy-donor complexes in highly <i>n </i> -type Ge doped with As, P and Sb. Journal of Physics Condensed Matter, 2016, 28, 335801.	1.8	13
24	Measurement and analysis of thermal conductivity of isotopically controlled silicon layers by timeâ€resolved Xâ€ray scattering. Physica Status Solidi (A) Applications and Materials Science, 2016, 213, 3020-3028.	1.8	2
25	Atomic transport during solid-phase epitaxial recrystallization of amorphous germanium. Applied Physics Letters, 2015, 107, .	3.3	8
26	Diffusion and Point Defects in Silicon Materials. Lecture Notes in Physics, 2015, , 1-67.	0.7	2
27	Impact of zinc halide addition on the growth of zinc-rich layers generated by sherardizing. Surface and Coatings Technology, 2015, 263, 66-77.	4.8	14
28	Response to "Comment on â€~Diffusion of n-type dopants in germanium' ―[Appl. Phys. Rev. 2, 0361 Applied Physics Reviews, 2015, 2, 036102.	01 (2015) 11.3)]3
29	Thermal conductivity of isotopically controlled silicon nanostructures. New Journal of Physics, 2014, 16, 015021.	2.9	21
30	Temperature dependence of ion-beam mixing in crystalline and amorphous germanium isotope multilayer structures. Journal of Applied Physics, 2014, 115, 023506.	2.5	7
31	Microstructural Studies of Fluorineâ€ <scp>I</scp> mplanted Titanium Aluminides for Enhanced Environmental Durability. Advanced Engineering Materials, 2014, 16, 52-59.	3.5	7
32	Reply to "Comment on â€~Contributions of vacancies and self-interstitials to self-diffusion in silicon under thermal equilibrium and nonequilibrium conditions' ― Physical Review B, 2014, 90, .	3.2	4
33	Phonon coherence in isotopic silicon superlattices. Applied Physics Letters, 2014, 105, 132104.	3.3	11
34	Defect engineering in germanium. Physica Status Solidi (A) Applications and Materials Science, 2014, 211, 109-117.	1.8	16
35	Light absorption in Ge nanoclusters embedded in SiO2: comparison between magnetron sputtering and sol–gel synthesis. Applied Physics A: Materials Science and Processing, 2014, 116, 233-241.	2.3	4
36	Diffusion of <i>n </i> -type dopants in germanium. Applied Physics Reviews, 2014, 1, 011301.	11.3	146

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37	Determination of nanoscale heat conductivity by time-resolved X-ray scattering. Thin Solid Films, 2013, 541, 28-31.	1.8	6
38	Antisites and anisotropic diffusion in GaAs and GaSb. Applied Physics Letters, 2013, 103, 142107.	3.3	11
39	Contributions of vacancies and self-interstitials to self-diffusion in silicon under thermal equilibrium and nonequilibrium conditions. Physical Review B, 2013, 88, .	3.2	49
40	Doping dependence of self-diffusion in germanium and the charge states of vacancies. Applied Physics Letters, 2013, 102, .	3.3	13
41	Radiation-enhanced self- and boron diffusion in germanium. Physical Review B, 2013, 87, .	3.2	21
42	Reduced thermal conductivity of isotopically modulated silicon multilayer structures. Applied Physics Letters, 2012, 101, 064103.	3.3	14
43	Cation diffusion in mixed cation silicate glasses under non-equilibrium conditions. Solid State Ionics, 2012, 222-223, 47-52.	2.7	3
44	A neutron reflectometry study on silicon selfâ€diffusion at 900 °C. Physica Status Solidi (B): Basic Research, 2012, 249, 2108-2112.	1.5	10
45	Structural and electrical properties of sol–gel derived Ge nanocrystals in SiO2 films. Applied Physics A: Materials Science and Processing, 2011, 103, 149-158.	2.3	9
46	A-centers and isovalent impurities in germanium: Density functional theory calculations. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2011, 176, 453-457.	3.5	25
47	Diffusion and doping issues in germanium. Microelectronic Engineering, 2011, 88, 452-457.	2.4	33
48	Suppression of donor-vacancy clusters in germanium by concurrent annealing and irradiation. Applied Physics Letters, 2011, 98, .	3.3	20
49	Diffusion of <i>E</i> centers in germanium predicted using GGA+ <i>U</i> approach. Applied Physics Letters, 2011, 99, 072112.	3.3	77
50	Fluorine effect on As diffusion in Ge. Journal of Applied Physics, 2011, 109, .	2.5	73
51	Ion-beam mixing in crystalline and amorphous germanium isotope multilayers. Journal of Applied Physics, 2011, 110, 093502.	2.5	5
52	Composition dependence of Si and Ge diffusion in relaxed Si1â^'xGex alloys. Journal of Applied Physics, 2010, 107, .	2.5	72
53	Dynamics of Network Formers and Modifiers in Mixed Cation Silicate Glasses. Zeitschrift Fur Physikalische Chemie, 2010, 224, 1677-1705.	2.8	3
54	Experiments and simulation on diffusion and activation of codoped with arsenic and phosphorous germanium. Journal of Applied Physics, 2010, 108, 024903.	2.5	25

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55	Fluorine codoping in germanium to suppress donor diffusion and deactivation. Journal of Applied Physics, 2009, 106, .	2.5	61
56	Intrinsic and extrinsic diffusion of indium in germanium. Journal of Applied Physics, 2009, 106, .	2.5	72
57	Interstitial-Mediated Diffusion in Germanium under Proton Irradiation. Physical Review Letters, 2009, 103, 255501.	7.8	58
58	Self- and foreign alkaline-earth diffusion in mixed cation silicate glasses. Solid State Ionics, 2009, 180, 109-115.	2.7	12
59	E centers in ternary Si1â^'xâ^'yGexSny random alloys. Applied Physics Letters, 2009, 95, .	3.3	64
60	Defect interactions in Sn1â^'xGex random alloys. Applied Physics Letters, 2009, 94, 252104.	3.3	65
61	Phosphorous clustering in germanium-rich silicon germanium. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2008, 154-155, 72-75.	3.5	51
62	Simultaneous diffusion of Si and Ge in isotopically controlled heterostructures. Materials Science in Semiconductor Processing, 2008, 11, 378-383.	4.0	20
63	Concentration of intrinsic defects and self-diffusion in GaSb. Journal of Applied Physics, 2008, 104, 093714.	2.5	25
64	Intrinsic and extrinsic diffusion of phosphorus, arsenic, and antimony in germanium. Journal of Applied Physics, 2008, 103, .	2.5	188
65	Correlation between self-diffusion in Si and the migration mechanisms of vacancies and self-interstitials: An atomistic study. Physical Review B, 2008, 78, .	3.2	36
66	P implantation into preamorphized germanium and subsequent annealing: Solid phase epitaxial regrowth, P diffusion, and activation. Journal of Vacuum Science & Technology B, 2008, 26, 430-434.	1.3	39
67	Diffusion and defect reactions between donors, C, and vacancies in Ge. I. Experimental results. Physical Review B, 2008, 77, .	3.2	117
68	Vacancy-mediated dopant diffusion activation enthalpies for germanium. Applied Physics Letters, 2008, 92, .	3.3	132
69	Self-diffusion in germanium isotope multilayers at low temperatures. Applied Physics Letters, 2008, 93,	3.3	106
70	Diffusion and defect reactions between donors, C, and vacancies in Ge. II. Atomistic calculations of related complexes. Physical Review B, 2008, 77, .	3.2	81
71	Nonlinear stability of mmi:math xmins:mmi="http://www.w3.org/1998/Math/Math/Mith/Math/Mith/Math/Mith/Math/Mith/Mith/Mith/Mith/Mith/Mith/Mith/Mi	3.2 > <mml:mi< td=""><td>63 1>1</td></mml:mi<>	63 1>1
72	Proton irradiation of germanium isotope multilayer structures at elevated temperatures. Journal of Applied Physics, 2008, 103, 033517.	2.5	18

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73	Bodycote Prize WinnerSherardising – galvanising steel with zinc from vapour phase. International Heat Treatment and Surface Engineering, 2008, 2, 49-54.	0.2	7
74	The vacancy in silicon: A critical evaluation of experimental and theoretical results. Journal of Applied Physics, 2008, 104, 076108.	2.5	58
75	Vacancy-arsenic clusters in germanium. Applied Physics Letters, 2007, 91, .	3.3	75
76	Zinc and gallium diffusion in gallium antimonide. Physical Review B, 2007, 75, .	3.2	24
77	Self- and foreign-atom diffusion in semiconductor isotope heterostructures. I. Continuum theoretical calculations. Physical Review B, 2007, 75, .	3.2	67
78	Self- and foreign-atom diffusion in semiconductor isotope heterostructures. II. Experimental results for silicon. Physical Review B, 2007, 75, .	3.2	105
79	Defect reactions in gallium antimonide studied by zinc and self-diffusion. Physica B: Condensed Matter, 2007, 401-402, 262-265.	2.7	8
80	Atomic transport in germanium and the mechanism of arsenic diffusion. Materials Science in Semiconductor Processing, 2006, 9, 471-476.	4.0	71
81	Advanced dopant and self-diffusion studies in silicon. Nuclear Instruments & Methods in Physics Research B, 2006, 253, 105-112.	1.4	6
82	Diffusion mediated by doping and radiation-induced point defects. Physica B: Condensed Matter, 2006, 376-377, 11-18.	2.7	27
83	Diffusion of silicon in crystalline germanium. Semiconductor Science and Technology, 2006, 21, 758-762.	2.0	71
84	Zinc diffusion in gallium arsenide and the properties of gallium interstitials. Physical Review B, 2005, 71, .	3.2	38
85	Copper related diffusion phenomena in germanium and silicon. Materials Science in Semiconductor Processing, 2004, 7, 113-124.	4.0	66
86	Radiation Enhanced Silicon Self-Diffusion and the Silicon Vacancy at High Temperatures. Physical Review Letters, 2003, 91, 245502.	7.8	71
87	Self-diffusion in 69Ga121Sb/71Ga123Sb isotope heterostructures. Journal of Applied Physics, 2001, 89, 5393-5399.	2.5	28
88	Zinc diffusion enhanced Ga diffusion in GaAs isotope heterostructures. Physica B: Condensed Matter, 2001, 308-310, 831-834.	2.7	11
89	Mechanism of zinc diffusion in gallium antimonide. Physica B: Condensed Matter, 2001, 308-310, 854-857.	2.7	21
90	Microscopic defects in silicon induced by zinc out-diffusion. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2000, 71, 160-165.	3.5	21

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91	Large disparity between gallium and antimony self-diffusion in gallium antimonide. Nature, 2000, 408, 69-72.	27.8	100
92	Diffusion Mechanisms and Intrinsic Point-Defect Properties in Silicon. MRS Bulletin, 2000, 25, 22-27.	3.5	92
93	Double-hump diffusion profiles of copper and nickel in germanium wafers yielding vacancy-related information. Applied Physics Letters, 2000, 77, 642-644.	3.3	54
94	Comment on "Self-Diffusion in Silicon: Similarity between the Properties of Native Point Defects― Physical Review Letters, 2000, 85, 4835-4835.	7.8	15
95	Point defects in silicon after zinc diffusion - a deep level transient spectroscopy and spreading-resistance profiling study. Semiconductor Science and Technology, 1999, 14, 435-440.	2.0	14
96	Enhanced and retarded Ga self-diffusion in Si and Be doped GaAs isotope heterostructures. Solid State Communications, 1999, 112, 301-314.	1.9	31
97	Diffusion in isotopically controlled semiconductor systems. Physica B: Condensed Matter, 1999, 273-274, 981-986.	2.7	9
98	Self- and interdiffusion in AlXGa1â^'XAs/GaAs isotope heterostructures. Applied Physics Letters, 1999, 74, 49-51.	3.3	43
99	Out-diffusion of Zn from Si: A method to study vacancy properties in Si. Journal of Applied Physics, 1998, 83, 8062-8064.	2.5	14
100	Silicon Self-Diffusion in Isotope Heterostructures. Physical Review Letters, 1998, 81, 393-396.	7.8	303
101	Self-Diffusion in Isotopically Controlled Heterostructures of Elemental and Compound Semiconductors. Materials Research Society Symposia Proceedings, 1998, 527, 335.	0.1	21
102	Properties of Vacancies in Silicon Determined by Out-Diffusion of Zinc from Silicon. Materials Research Society Symposia Proceedings, 1998, 532, 219.	0.1	1
103	Kinetics of Interstitial-Substitutional Exchange of Zn, Pt, and Au in Si: Experimental Results and Theoretical Calculations. Physica Status Solidi A, 1996, 158, 47-55.	1.7	17
104	Properties of intrinsic point defects in silicon determined by zinc diffusion experiments under nonequilibrium conditions. Physical Review B, 1995, 52, 16542-16560.	3.2	295
105	Interstitial–Substitutional Diffusion Kinetics and Dislocation-Induced Trapping of Zinc in Plastically Deformed Silicon. Physica Status Solidi A, 1993, 137, 499-514.	1.7	26
106	Diffusion and solubility of copper, silver, and gold in germanium. Physical Review B, 1991, 43, 14465-14477.	3.2	91
107	Properties of Point Defects in Silicon: New Results after a Long-Time Debate. Solid State Phenomena, 0, 205-206, 151-156.	0.3	5